

GEMOLOGICAL INSTITUTE

## **ELECTRONIC COPY**

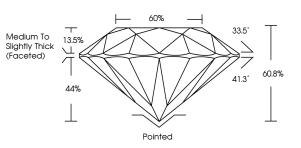
#### LABORATORY GROWN DIAMOND REPORT

### PROPORTIONS

July 31, 2024	
IGI Report Number	LG645424477
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.18 - 8.18 X 4.97 MM
GRADING RESULTS	
Carat Weight	2.04 CARATS
Color Grade	E CARLES CONTRA
Clarity Grade	VS 2
Cut Grade	IDEAL
ADDITIONAL GRADING	NFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	(G) LG645424477

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



LG645424477

Report verification at igi.org



Sample Image Used

# July 31 2024

July 31, 2024	
IGI Report Number	LG645424477
Description LABO	RATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.18 - 8.18 X 4.97 MM
GRADING RESULTS	
Carat Weight	2.04 CARATS
Color Grade	E
Clarity Grade	VS 2
Cut Grade	IDEAL

60% 33.5° 13.59 Medium To Slightly 60.8% Thick 41.3° 44% (Faceted) Pointed

#### ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	1631 LG645424477
Comments: This Laboratory created by Chemical Vapo process. Type IIa	

**KEY TO SYMBOLS** 

**CLARITY CHARACTERISTICS** 

Red symbols indicate internal characteristics. Green symbols indicate external characteristics.

С	DLO	R	
	E	E	

DE	F	G	ΗI	J	Faint	Very Light	Light
CLARI	TY						
IF		VVS	1 - 2		VS <sup>1-2</sup>	SI <sup>1-2</sup>	1 - 3
Internally Flawless			/ Very htly Inc	luded	Very Slightly Included	Slightly Included	Included



# G

45424477	MM	2.04 CARATS		VS 2	IDEAL	60.8%	808	Medium To Slightly Thick (Facefed)	Pointed	BKCELLENT	EXCELLENT	NONE	1gg) LG645424477	Comments: Na Lichodov Grown Damord was and by Chemical Vigor Deposition (CD) growth process. Itpe IId
July 31, 2024 161 Report No 1.6645424477 ROUND BRILLIANT	8.18 - 8.18 X 4.97 MM	Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence	Inscription(s)	Comments: This Laboratory Grown created by Chemical (CVD) growth process Type IId